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MOEMS and Miniaturized Systems XIV

**Wibool Piyawattanametha
Yong-Hwa Park**
Editors

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The CID Number appears on each page of the manuscript. The complete citation is used on the first page, and an abbreviated version on subsequent pages.

Contents

vii	<i>Authors</i>
ix	<i>Conference Committee</i>

MICROSCANNER I

9375 05	Hybrid assembled micro scanner array with large aperture and their system integration for a 3D ToF laser camera [9375-4]
9375 06	MEMS scanner mirror based system for retina scanning and in eye projection [9375-5]
9375 07	Rotational MEMS mirror with latching arm for silicon photonics [9375-6]

MICROSCANNER II

9375 09	Centimeter-scale MEMS scanning mirrors for high power laser application (Invited Paper) [9375-7]
9375 0A	High brightness MEMS mirror based head-up display (HUD) modules with wireless data streaming capability (Best Paper Award) [9375-8]
9375 0B	A study of integrated position sensors for PZT resonant micromirrors [9375-9]
9375 0C	2D tilting MEMS micro mirror integrating a piezoresistive sensor position feedback [9375-10]

MOEMS FOR SENSING APPLICATIONS

9375 0D	Spatially resolved contrast measurement of diffractive micromirror arrays [9375-11]
9375 0E	Image based wavefront compensation with deformable mirror for small satellite remote sensing [9375-12]
9375 0F	Advanced MEMS spectral sensor for the NIR [9375-13]
9375 0G	Far infrared microbolometers for radiometric measurements of ice cloud [9375-14]
9375 0H	Compact MEMS mirror based Q-switch module for pulse-on-demand laser range finders [9375-15]
9375 0I	Tuning mechanical resonant frequencies of nanoelectromechanical systems with light [9375-16]

MOEMS FOR IMAGING APPLICATIONS

- 9375 0J **Large-aperture MOEMS Fabry-Perot interferometer for miniaturized spectral imagers** [9375-17]
- 9375 0K **Large size MOEMS Fabry-Perot interferometer filter for focal plane array hyperspectral imaging** [9375-18]
- 9375 0L **Technological platform for vertical multi-wafer integration of miniature imaging instruments** [9375-19]
- 9375 0M **A biaxial PZT optical scanner for pico-projector applications** [9375-20]

MOEMS COMPONENTS AND SYSTEMS I

- 9375 0N **CMOS compatible fabrication of 3D photonic crystals by nanoimprint lithography** [9375-21]
- 9375 0O **Piezoelectrically driven translatory optical MEMS actuator with 7mm apertures and large displacements** [9375-22]
- 9375 0P **Multi-wafer bonding technology for the integration of a micromachined Mirau interferometer** [9375-23]
- 9375 0Q **Tunable optical buffer based on III-V MEMS design** [9375-24]
- 9375 0R **Integrated packaging of 2D MOEMS mirrors with optical position feedback** [9375-25]

MOEMS COMPONENTS AND SYSTEMS II

- 9375 0S **Improvement of Varioptic's liquid lens based on electrowetting: how to obtain a short response time and its application in the design of a high resolution iris biometric system** [9375-26]
- 9375 0T **Volume refractometry of liquids using stable optofluidic Fabry-Pérot resonator with curved surfaces (Best Student Paper Award)** [9375-27]
- 9375 0U **Fiber-coupled Fabry-Pérot notch filter combining in-plane axis, high speed MEMS tunability and large etching depth** [9375-28]
- 9375 0V **MEMS-based frequency modulation of fiber ring laser** [9375-29]
- 9375 0W **Large MOEMS diffraction grating results providing an EC-QCL wavelength scan of 20%** [9375-30]
- 9375 0X **Resonant micro optic gyro using tens of centimeters long optical fiber coil** [9375-31]
- 9375 0Y **Modeling and simulations of new electrostatically driven, bimorph actuator for high beam steering micromirror deflection angles** [9375-32]

POSTER SESSION

- 9375 0Z **Mechanical analysis and optimal design of a new kind of spherical mobile robot with two modes of locomotion** [9375-33]
- 9375 12 **Optical metrology of AlN piezomachined ultrasonic transducer arrays and piezopumps** [9375-36]

Authors

Numbers in the index correspond to the last two digits of the six-digit citation identifier (CID) article numbering system used in Proceedings of SPIE. The first four digits reflect the volume number. Base 36 numbering is employed for the last two digits and indicates the order of articles within the volume. Numbers start with 00, 01, 02, 03, 04, 05, 06, 07, 08, 09, 0A, 0B...0Z, followed by 10-1Z, 20-2Z, etc.

Al-Arifi, Fares, 0V	Hofmann, U., 09, 0O
Al-Otaibi, Mohammed, 0V	Horak, Peter, 0Q
Angelescu, Dan, 0T	Hough, Nathaniel, 0H
Antila, Jarkko, 0F	Hwu, J., 0K
Atwood, Bryan, 0H	Ikegami, K., 0M
Baranski, M., 0L	Janeiro, Ricardo, 12
Bargiel, Sylwester, 0L, 0P	Janes, J., 09, 0B, 0O
Baulig, Claudia, 05	Jin, Zhonghe, 0X
Baumgart, M., 0R	Kamenz, Joerg, 0W
Bayat, D., 0C	Kantojärvi, Uula, 0F
Beaulieu, Philippe-Olivier, 07	Kasturi, Abhishek, 0A, 0H
Benecke, W., 09, 0B, 0O	Kenyon, Anthony J., 0Q
Berndt, Dirk, 0D	Khalil, Diaa, 0T, 0U, 0V
Bleh, Daniela, 0W	Khalil, Kamal, 0V
Bourouina, Tarik, 0T	Kim, T. S., 0K
Brière, Jonathan, 07	Knobbe, Jens, 06
Burger, Benjamin, 0S	Koyama, T., 0M
Châteauneuf, François, 0G	Kremer, M. P., 0R
Chau, Fook Siong, 0I	Kubby, J., 0K
Chee, J., 0K	Langner, Andreas, 0J
Cole, Brian J., 0H	Lani, S., 0C
Coutu, Ronald A., 0Y	Lenzhofer, M., 0R
Dallmann, Hans-Georg, 05, 06	Limkraitassiri, Kevin, 0H
Deng, Jie, 0I	Liu, Huiyun, 0Q
Despont, M., 0C	Lullin, Justine, 0P
Drabe, Christian, 0W	Ma, Huilian, 0X
Eibelhuber, M., 0N	Mądzik, Mateusz, 12
Eltagoury, Yomna M., 0U, 0V	Mäkynen, Jussi, 0F
Flores, Raquel, 12	Malak, Maurine, 0T
Frömel, Joerg, 0L, 0P	Mallas, C., 09
Gaber, Noha, 0T	Mannila, Rami, 0J
Gawlitza, P., 09	Marty, Frédéric, 0T
Gessner, Thomas, 0P	Meimon, Serge C., 0S
Glinsner, T., 0N	Menard, Michaël, 07
Goldberg, Lew, 0H	Merten, André, 0W
Gorecki, Christophe, 0L, 0P	Milanović, Veljko, 0A, 0H
Grahmann, Jan, 0W	Miyamura, Norihide, 0E
Grasshoff, Thomas, 05	Nabki, Frederic, 07
Grüger, Heinrich, 06	Nettleton, John E., 0H
Gruhne, C., 09	Ng, Wing H., 0Q
Gupta, N., 0K	Ngo Phong, Linh, 0G
Gu-Stoppel, S., 0B, 0O	Nguyen, Minh Chau, 0S
Hachtel, Volker, 0A	Ortega-Delgado, M., 09
Hannweber, J., 09	Ostendorf, Ralf, 0W
Hassan, Khaled, 0V	Oulachgar, Hassane, 0G
Heber, Jörg, 0D	Passilly, Nicolas, 0L, 0P
Heinrich, F., 0B	Petit, Cyril, 0S
Herrmann, Andreas, 0W	Podoliak, Nina, 0Q
Herwig, P., 09	Proulx, Christian, 0G

Pügner, Tino, 06
 Quenzer, H.- J., 0B, 0O
 Richalot, Elodie, 0T
 Rissanen, Anna, 0J
 Rückerl, Florian, 0D
 Sabry, Yasser M., 0U, 0V
 Saidani, Menouer, 07
 Saito, T., 0M
 Sandner, Thilo, 05
 Schelinski, Uwe, 06
 Schenk, Harald, 0D
 Schwarzenberg, Markus, 05
 Schwarzer, Stefan, 05
 Senger, F., 09
 Shebl, Ahmed, 0U, 0V
 Shorte, Spencer, 0D
 Sicker, Cornelius, 0D
 Soliman, Mostafa, 0U, 0V
 Starman, LaVern, 0Y
 Stewart, William J., 0Q
 Stoppel, F., 0O
 Su, Yu, 0H
 Suhonen, Janne, 0F
 Sun, Hanxu, 0Z
 Sun, Ping, 0Z
 Taha, Inas, 12
 Takemura, Yuto, 0T
 Tammi, Matti, 0F
 Tian, Feng, 0I
 Tinevez, Jean-Yves, 0D
 Tortschanoff, A., 0R
 Toshiyoshi, H., 0M
 Uhrmann, T., 0N
 v. Wantoch, T., 09
 Velicu, S., 0K
 Viegas, Jaime, 12
 Viherkanto, Kai, 0J
 Wagner, Michael, 0D
 Walton, John P., 0Y
 Wang, Linglan, 0X
 Wang, Wei-Shan, 0L, 0P
 Wetzig, A., 09
 Wiemer, Maik, 0L, 0P
 Wildenhain, Michael, 05
 Woittennek, Franziska, 06
 Wu, Jiang, 0Q
 Wünsch, D., 0L
 Yasuda, Y., 0M
 Zhang, Jianjie, 0X
 Zhao, Wei, 0Z
 Zhou, Guangya, 0I

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- 1 Miniature Instruments for Endoscopic Microscopy: Joint Session with Conferences 9304 and 9375
Wibool Piyawattanametha, King Mongkut's Institute of Technology Ladkrabang (Thailand) and Chulalongkorn University (Thailand)
- 2 Microscanner I
Yong-Hwa Park, Samsung Advanced Institute of Technology (Korea, Republic of)
- 3 Microscanner II
Guangya Zhou, National University of Singapore (Singapore)
- 4 MOEMS for Sensing Applications
Jan Grahmann, Fraunhofer-Institut für Photonische Mikrosysteme (Germany)
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- 6 MOEMS Components and Systems I
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- 7 MOEMS Components and Systems II
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